

Notice of References Cited

Application/Control No.

09/657,506

Applicant(s)/Patent Under
Reexamination
SON ET AL.

Examiner

David Y. Chung

Art Unit

2871

Page 1 of 1

U.S. PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Name | Classification |
|---|---|--|-----------------|-----------------|----------------|
| | A | US-6,088,079 | 07-2000 | Kameyama et al. | 349/185 |
| | B | US-5,691,789 | 11-1997 | Li et al. | 349/98 |
| | C | US-6,377,325 | 04-2002 | Faris et al. | 349/98 |
| | D | US-6,433,853 | 08-2002 | Kameyama et al. | 349/176 |
| | E | US-5,999,243 | 12-1999 | Kameyama et al. | 349/185 |
| | F | US-6,016,177 | 01-2000 | Motomura et al. | 349/98 |
| | G | US-6,342,934 | 01-2002 | Kameyama et al. | 349/98 |
| | H | US-6,103,323 | 08-2000 | Motomura et al. | 428/1.3 |
| | I | US-6,166,790 | 12-2000 | Kameyama et al. | 349/96 |
| | J | US-6,339,501 | 01-2002 | Kameyama et al. | 359/485 |
| | K | US- | | | |
| | L | US- | | | |
| | M | US- | | | |

FOREIGN PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Country | Name | Classification |
|---|---|--|-----------------|---------|------|----------------|
| | N | | | | | |
| | O | | | | | |
| | P | | | | | |
| | Q | | | | | |
| | R | | | | | |
| | S | | | | | |
| | T | | | | | |

NON-PATENT DOCUMENTS

| * | | Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) |
|---|---|---|
| | U | |
| | V | |
| | W | |
| | X | |

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.